SEP 2 8 2009

PTOL-413A (07-09)
Approved for use through 07/31/2012, OM9 0851-0031
Trademark Office: U.S. DEPARTMENT OF COMMERCE.

Applicant Initiated Interview Request Form						
Application No.: 10/583,534-Conf. #4954 First Named Appli Examiner: M. L. Sekul Art Unit: 4124				: Xiaodong Li s of Application: Published		
Tentative Participant	ts:					
(1) Exr. Sekul (2) SPE West						
(3) Atty. Davin Chin (4) Atty. Christopher Daley-Watson						
Proposed Date of Interview: Sept. 28, 2009 Proposed Time: 1:00 PM Eastern						
Type of Interview Requested: (1) X Telephonic (2) Personal (3) Video Conference						
Exhibit To Be Shown or Demonstrated: XES X NO						
If yes, provide brief description:						
Issues To Be Discussed						
Issues (Roj., Obj., etc)	Claims/ Fig. #s	Prior Art		Discussed	Agreed	Not Agreed
(1) <u>Rej.</u>	Various	van Nee, N McGo				
(2)						
(3)						
(4)						
Continuation Sheet Attached						
Brief Description of Arguments to be Presented: Discussion of applicants' technology and differences between applied references, e.g., Miyoshi, and						
applicants' technology.						
An interview was conducted on the above-identified application on NOTE:						
This form should be completed by applicant and submitted to the examiner in advance of the interview (see MPEP §713.01).						
This application will not be delayed from issue because of applicant's failure to submit a written record of this						
interview. Therefore, applicant is advised to file a statement of the substance of this interview (37 CFR 1.133(b)) as soon as possible.						
as soon as possible.	///	~				
Applicant/Applicant's Representative Signature Examiner/SPE Signature						
Typed/Printed Name of Applicant or Representative						
58,413						
Registration Number, if applicable						